



Docket No. EATNP154US

03-IMP-014

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application of:

Applicant: Alexander S. Perel

Application No.: 10/803,439

For: IN-SITU MONITORING ON AN ION IMPLANTER

Filing Date: March 18, 2004

Examiner: Bernard E. Souw

Art Unit: 2881

REPLY TO OFFICE ACTION DATED DECEMBER 28, 2005

Mail Stop Amendment
Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Examiner:

Favorable reconsideration of the above-identified application is respectfully requested in view of the following amendments and remarks.